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Application/Control No.	Applicant(s)/Patent under Reexamination
10/052,113	LEE ET AL.
Examiner	Art Unit
Krista M. Flanagan	2631

SEARCHED			
Class	Subclass	Date	Examiner
375	211 214 215 354 371 373 355	4/6/2005	KMF
327	164 201	4/6/2005	KMF
327	291 385	4/6/2005	KMF
327	386	4/6/2005	KMF
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	354	9/23/2005	KMF

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST (Bocure)	4/6/2005	KMF
Inventorship	4/6/2005	KMF
EAST	4/14/2005	KMF
West - Bocure, see attached search notes	4/18/2005	KMF
East - 375/\$\$\$.ccls. and (align\$ near2 clock) and ((multiplier multiplication multiply multiplies) near3 circuit)	9/28/2005	KMF